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Appl. No.: 10/523,985  
Applicant: Tetsuji ZAMA  
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Examiner: Jaison P. Thomas

Confirmation No. 1325

Title: PROCESS FOR PRODUCING CONDUCTIVE POLYMER  
Docket No. : 3103.110

**FIRST INFORMATION DISCLOSURE STATEMENT**

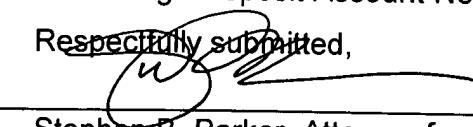
**Mail Stop Amendment**  
Director of the United States Patent  
and Trademark Office  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Dear Sir:

This Information Disclosure Statement (IDS) is submitted in accordance with 37 C.F.R. §§1.97, 1.98, and it is requested that the information set forth in this statement and in the listed documents be considered during the pendency of the above-identified application, and any other application relying on the filing date of the above-identified application or cross-referencing it as a related application.

Counsel certifies that, upon information and belief, each item of information listed herein was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this IDS. Therefore, no fee is believed due; however, should the Commissioner deem a fee is required, authorization is given to charge Deposit Account No. 50-4080.

Respectfully submitted,

By 

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I, Stephen Parker, hereby certify that this document is being deposited with the United States Postal Service with sufficient postage for first class mail in an envelope addressed to the Mail Stop Amendment address above, or being facsimile transmitted to the USPTO (571) 273-8300, on November 6, 2008.